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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: DALE HARRISON

Filed: SEPTEMBER 23, 2003

For: SEMICONDUCTOR PROCESSING TECHNIQUES UTILIZING
VACUUM ULTRAVIOLET REFLECTOMETER

Serial No.: 10/669,030

Group Art Unit: 2878

Examiner: UNKNOWN

Atty Dkt: METR:002

Pursuant to 37 C.F.R. 1.8, I certify that this correspondence is being deposited with the U.S. Postal Service in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date below:

10-28-04 Diane C. Petts
Date Name

ATTN: OFFICIAL DRAFTSMAN
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUBMISSION OF FORMAL DRAWINGS

Applicants hereby submit the formal drawings for the above-referenced application and request that these drawings be accepted for filing.

Respectfully submitted,

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